



I prefer to take the train.”

Joris Kaal (a week ago)

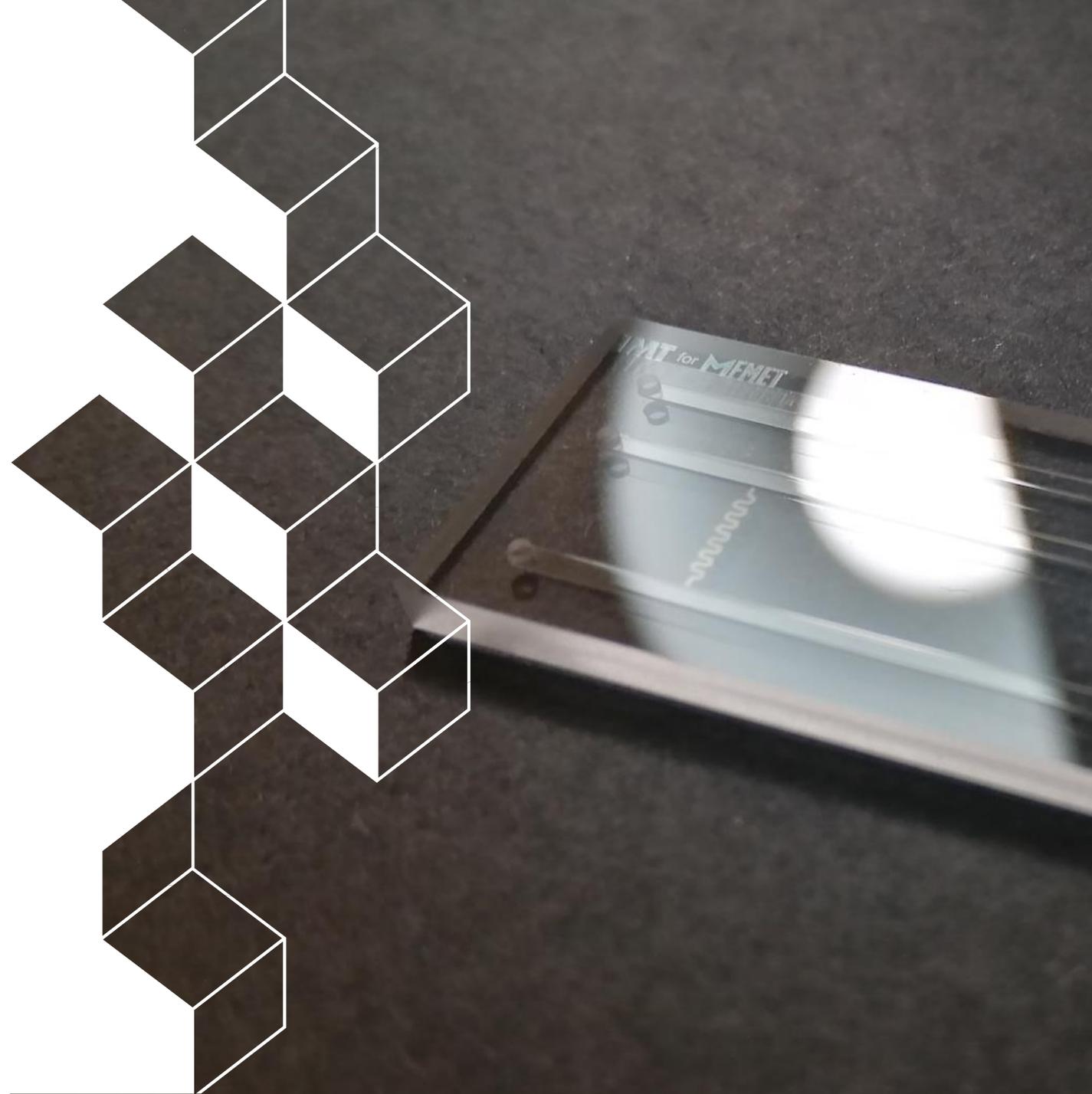




Dimensional characterization of microfluidic chips

What we can and can't do

Joris Kaal, CEA-Leti



Why?

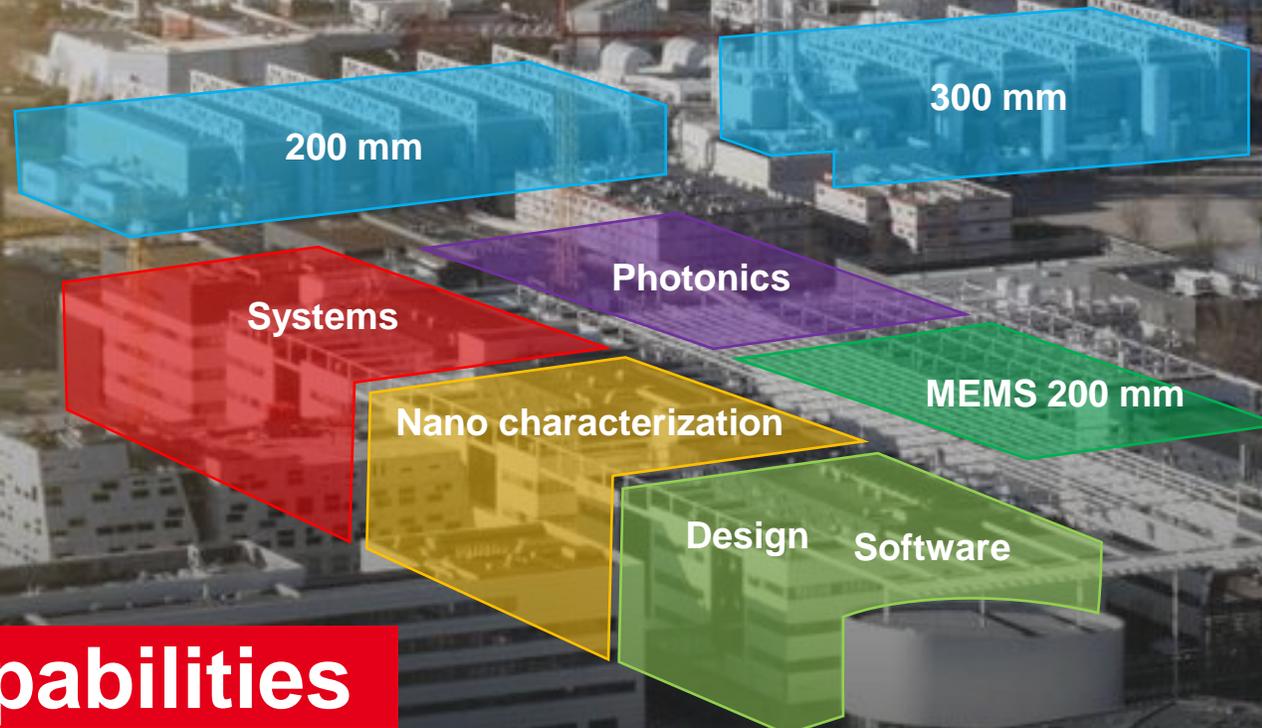


01

**GENERAL NEED
MEASUREMENT
METHODS**

02

**DIMENSIONS ARE
BASIS OF OTHER
MEASUREMENTS**



CEA-Leti's capabilities

- › 11 000 m² of cleanroom dedicated to nanofabrication
- › 800 people divided in 4 shifts
- › Supported by a **nanocharacterization platform**

PRISM

Research Platform for Integration, Surface functionalization and Microfabrication



Polymer micro-machining and aluminium moulds



Thermoforming and heat sealing



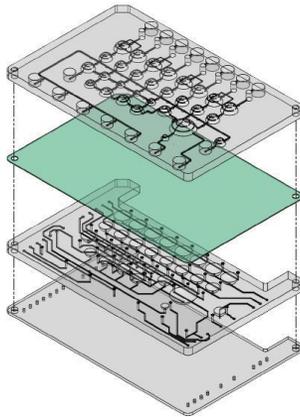
Atmospheric plasma



Silicone film lamination



Electrochemical sensors and surface functionalisation



Generic library for standardised and ISO-conform building blocks



Cleanroom environment

How are we measuring?



Protocol
(CEA)
1

Optical
profilometry

Protocol
(LNE)
2

Optical
microscopy

Protocol
(UofG)
3

Tiled digital
imagery

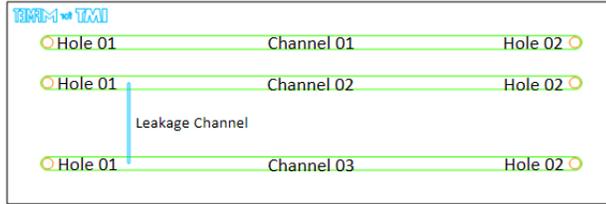
Protocol
(UofG)
4

Confocal
microscopy

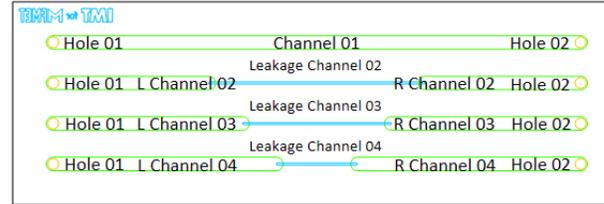
What are we measuring?



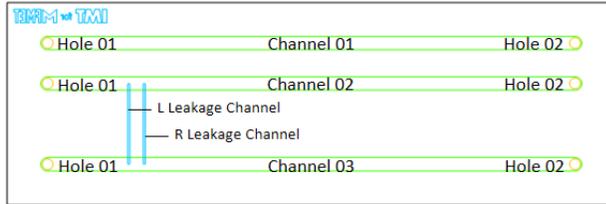
Design 01



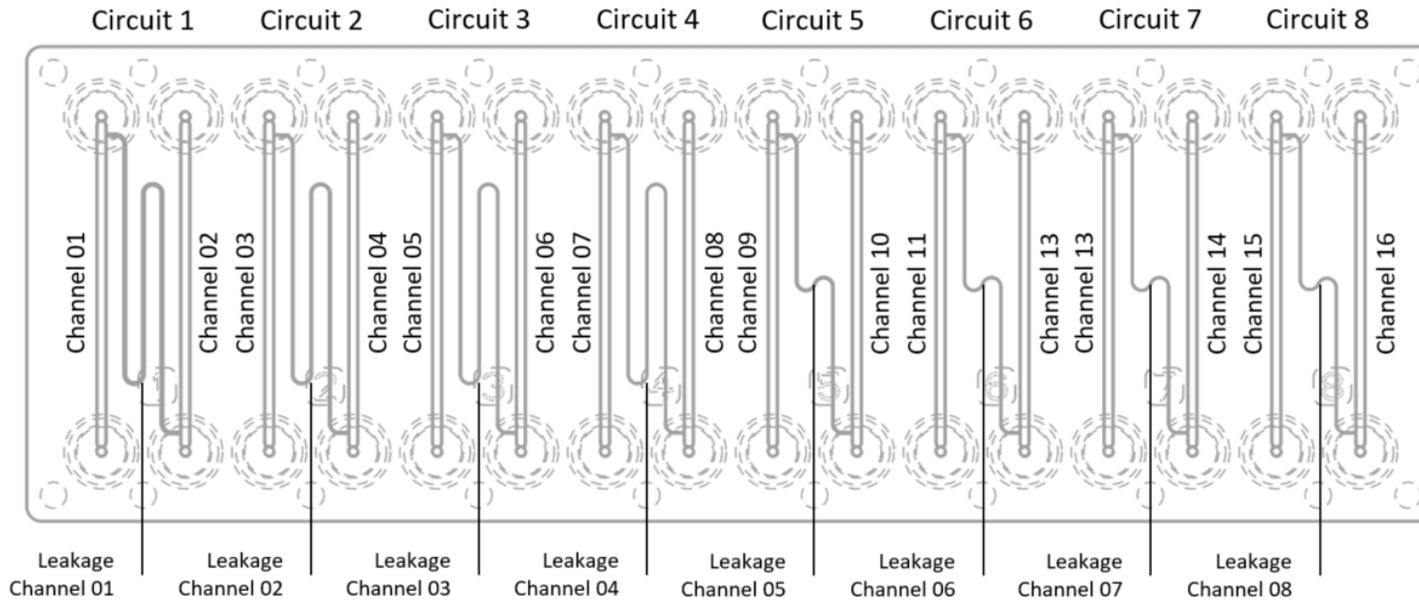
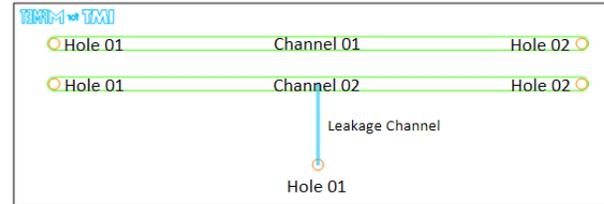
Design 05



Design 02



Design 06

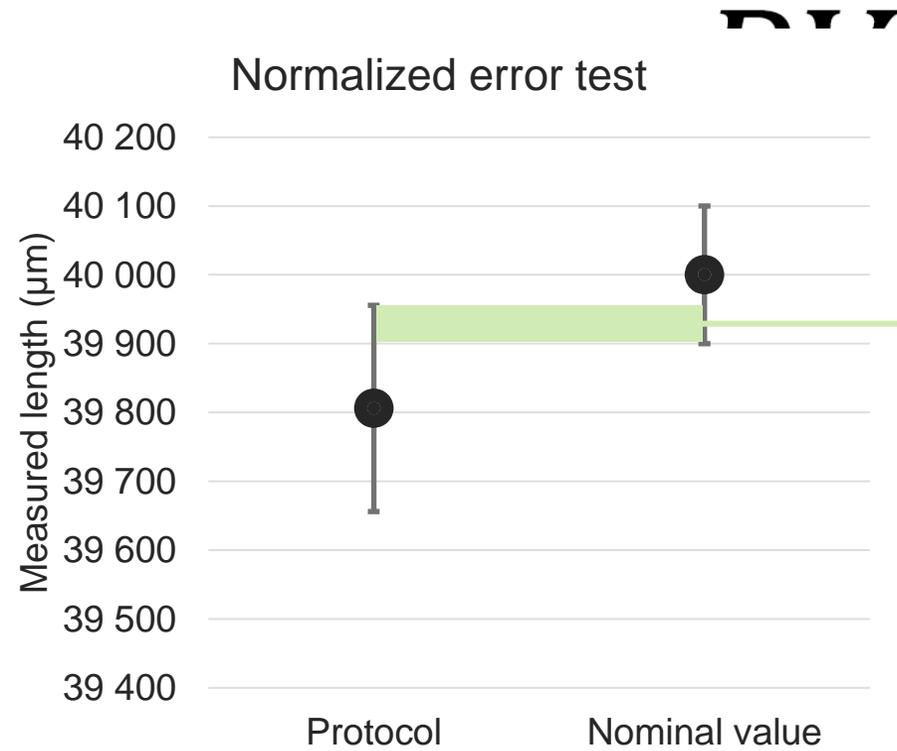


263 © Bio glass
POPAS © COC

How do we compare?



$$E_n = \frac{\sigma}{\mu} \sqrt{\frac{1}{n} \sum_{i=1}^n (x_i - \mu)^2}$$



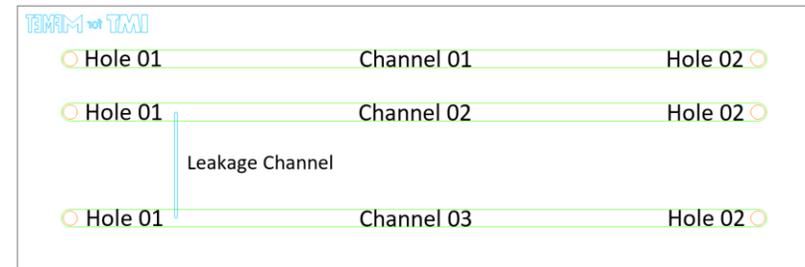
$$\frac{|E_n|}{1} \leq 1$$

Normalized error values in glass



	<u>Diameter Hole 01</u>	<u>Diameter Hole 02</u>	<u>Width</u>	<u>Depth</u>	<u>Length</u>
Protocol 1	0.16	0.33	-0.93	-7.81	0.02

Design 01



Material influence (xy-plane)



Optical profilometer vs. Optical profilometer

on TOPAS® COC

Width

Average
measured

Standard
deviation

Channel 01	503.1 μm	0.1 μm (0.0 %)
Leakage Channel 01	108.5 μm	0.1 μm (0.1 %)
Channel 02	508.1 μm	0.1 μm (0.0 %)

On D263® Bio glass

Width

Average
measured

Standard
deviation

Channel 01	991.3 μm	0.2 μm (0.0 %)
Channel 02	992.1 μm	0.2 μm (0.0 %)
Channel 03	992.4 μm	0.2 μm (0.0 %)
Leakage Channel	143.0 μm	0.5 μm (0.3 %)

Material influence (depth)



Optical profilometer vs. Optical profilometer

on TOPAS® COC

Depth

Average
measured

Standard
deviation

Channel 01	358.0 μm	1.7 μm (0.5 %)
Leakage Channel 01	123.6 μm	1.8 μm (1.4 %)
Channel 02	372.9 μm	2.7 μm (0.7 %)

On D263® Bio glass

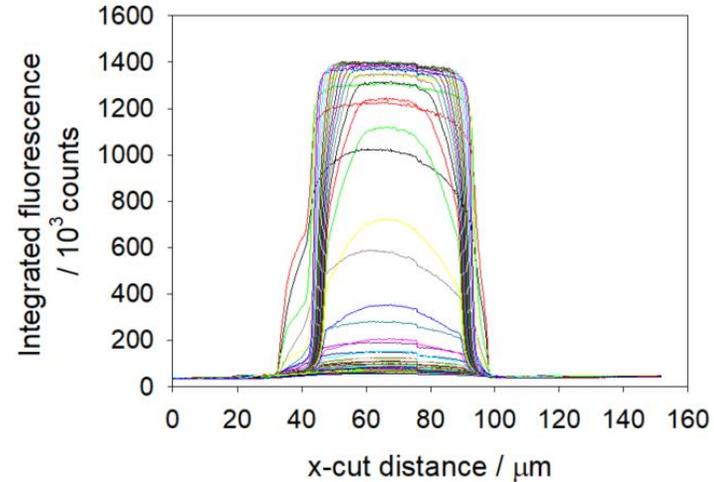
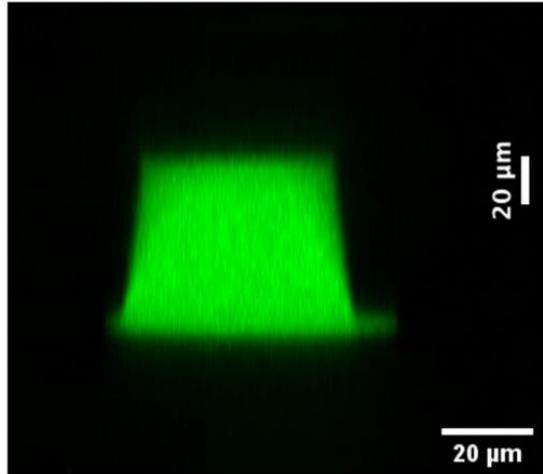
Depth

Average
measured

Standard
deviation

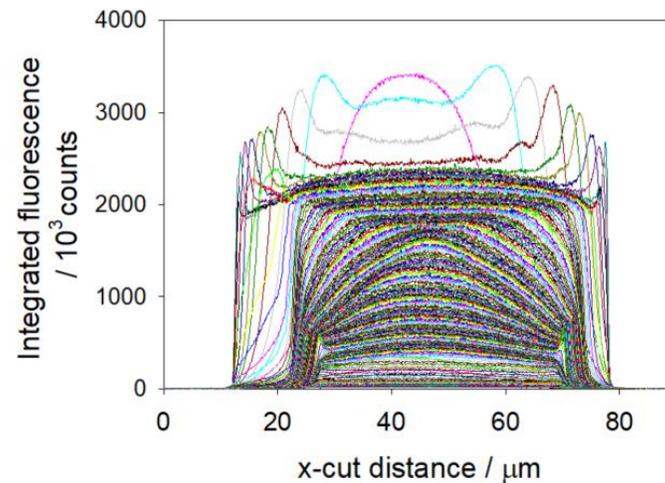
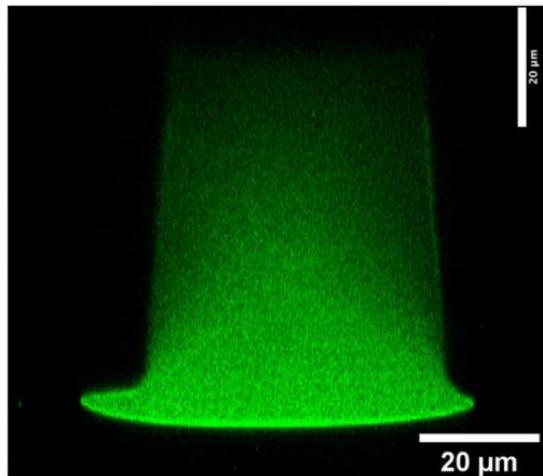
Channel 01	13.8 μm	4.6 μm (33.0 %)
Channel 02	17.9 μm	1.3 μm (7.6 %)
Channel 03	20.2 μm	3.3 μm (16.3 %)
Leakage Channel	N/A	N/A

A way to solve depth measurements



Zeiss LSM 510
x20 NA = 0.5 objective
resolution in Z of 2.07 μm

Estimated channel depth: 74.5 ± 4 μm



Zeiss LSM 510
x100 NA = 1.3 objective
resolution in Z of 0,44 μm

Estimated channel depth: 73.0 ± 0.8 μm

Conclusion

- All protocols are consistent
- D263© Bio glass and TOPAS© COC are comparably compatible with measurements
- Depth measurements are a challenge

Outlook

- How to do depth measurements?
 - Improve optical profilometry?
 - Zeta plane imagery?
 - Confocal microscopy?
- Compare more materials





A big thanks to:

Huabing Yin, Andrew Glidle, Nicolas Feltin, Marc Lelong, Kevin Romieu, Elsa Batista

Vania Silverio, Henne van Heeren, Christina Pecnik, Elena Müller, Winfried Arens, Florestan Ogheard, Thomas Schrøder Djaugberg, Henrik Kjeldsen, Oliver Büker, Sabrina Kartmann, Suvajyoti Guha

And all other MFMET partners



The EMPIR initiative is co-funded by the European Union's Horizon 2020 research and innovation programme and the EMPIR Participating States

